



ITW

Docket No.: H6808.0002/P002-A  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Tohru Ishitani et al.

Application No.: 10/803,932

Confirmation No.: 6731

Filed: March 19, 2004

Art Unit: 2858

For: APPARATUS FOR INSPECTING DEFECTS  
OF DEVICES AND METHOD OF  
INSPECTING DEFECTS

Examiner: J. Teresinski

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated October 1, 2004 (Paper No. 20040924), please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.